

ASMMC.036AUS

IN THE UNITED STATES PATENT AND TRADEMARK OF

Applicant

Sophie et al.

Appl. No.

09/975,466

Filed

October 9, 2001

For

IN SITU REDUCTION OF

COPPER OXIDE PRIOR TO

SILICON CARBIDE

DEPOSITION

Examiner

Kielin

Group Art Unit

2813

Response to Office Action

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed Commissioner for Patents, P.O. Box 1450

Alexandria, VA 22313-1450, on

October 10, 2003 (Date)

Andrew N. Merickel, Reg. No.53,317

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Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Office Action mailed on July 11, 2003. Applicants respectfully request consideration of the Remarks beginning on page 2 of this paper.